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Docket No. 10936-66

CERTIFICATE OF MAI

I hereby certify that this paper being deposited with the United States Postal Service with sufficient ostage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 or Cpull 12, 2002.

PATENT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE PROPERTY OF THE PROPERTY OF TH

Applicant:

Hideki Kitamura et al

Paper No.:

Serial No.:

10/019,858

Group Art Unit:

1752

Filing Date:

November 9, 2001

Examiner:

For:

Semiconductive Polyvinylidene Fluoride Resin Composition

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 1.97-1.98, Applicants cite and submit copies of the references listed on the attached Form PTO-1449.

Applicants note that Japanese Reference No. 47-3535 corresponds with U.S. Patents Nos. 3,703,569 and 3,829,408 and Japanese Reference No. 51-111337 corresponds with U.S. Patent No. 4.013,531. English language abstracts of the remaining Japanese language references are provided.

Since the present Statement is submitted prior to issuance of a first Official Action, no statement or fee under 37 C.F.R. 1.97 is required.

Respectfully submitted,

Holly D. Kozlowski, Reg. No. 30,468

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255 E. Fifth Street

Cincinnati, Ohio 45202

(513) 977-8568

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LIST OF PATENTS AND PUBLICATIONS APPLICANT Hideki Kitamura et al													
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	af	51-	1	1	()	6	5	8	Sep. 30, 1976	Japan 'w,'English abstract			
	ıg	54-	1	2	-	8	. 1	2	Oct. 4, 1979	Japan (w./English abstract)			
	ah	60-	1	7	7	()	6	4	Sep. 11, 1985	Japan (w./English abstract)			
	સાં	61-	7	2	0	6	1		Apr. 14, 1986	Japan [w,'English abstract)			
	aj	55-	2	6	9	-	3		Jul. 17, 1980	Japan [w/English abstract)			
	ak	8-	2	7	2	2	()	8	Oct. 18, 1996	Japan [w,/English abstract)			
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	am	Γ,	0	()	3	1	()	0	Jan. 6, 1995	Japan (w./English abstract)			
	an	6-	3	2	9	8	6	1	Nov. 29, 1994	Japan w./English abstract)			
	ао	11-	0	2	9	6	7	8	Feb. 2, 1999	Japan (w,/English abstract)			
	ар	11-	3	2	3	()	5	(1)	Nov. 26, 1999	Japan (w/English abstract)			
OTHER ART (INCLUDE)G AUTHOR, TITLE, DATE, PERTINERT PAGES, ETC)													
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPLP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
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